

Appl. No. 10/634,512
Reply to Office Action of September 3, 2004

PATENT
Attorney Docket No.: 022331-000220US

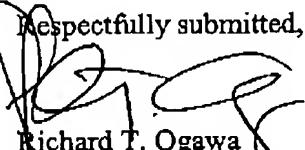
REMARKS/ARGUMENTS

In response to the restriction for this application, Applicants respectfully elect to prosecute Group I, Claims 1-25 drawn to the method of making a substrate structure, classified in class 438, subclass +1. Claims 26-32 have been canceled.

CONCLUSION

In view of the foregoing, Applicants believe all claims now pending in this Application are in condition for allowance. The issuance of a formal Notice of Allowance at an early date is respectfully requested.

If the Examiner believes a telephone conference would expedite prosecution of this application, please telephone the undersigned at 650-326-2400.

Respectfully submitted,

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Attachments
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